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CHARACTERISTICS OF NO_x ADSORPTION AND SURFACE CHEMISTRY ON IMPREGNATED ACTIVATED CARBON

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ABSTRACT

Adsorption characteristics of NO_x were studied with granular activated carbon (GAC) impregnated with potassium hydroxide (KOH). To confirm the selective adsorptivity of KOH-impregnated activated carbon (K-IAC) to NO_x in a fixed-bed adsorption column, temperature of 303–403K, linear velocity of 10–32 cm/sec, and effect of added oxygen were observed. Using scanning electron microscopy (SEM), time of flight secondary ion mass spectrometry (ToF-SIMS), and SIMS depth profile, surface-reaction phenomena of adsorbent, caused by the KOH impregnation and NO_x adsorption, were investigated. NO₂ adsorbs by chemical reaction with impregnated KOH, from which NO is generated. When oxygen exists, the NO again adsorbs to NO₂ with oxygen chemisorbed on the surface, which increases the adsorptivity. In the results of ToF-SIMS and SIMS depth profile,

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NO_2^- and NO_3^- increased at the surface distribution by forming oxide crystals of KNO_2 and KNO_3 due to bond formation with potassium ions. The SIMS depth profile of KO^- ensured that KOH provided the selective adsorption site of NO_x . In the mechanism studied, the basic character was led on K-IAC by surface basic OH^- ions of KOH, oxidation rate from KNO_2 to KNO_3 was delayed, and adsorptivity of K-IAC to NO_x was improved.

Key Words: NO_x ; KOH; Impregnated activated carbon; Time of flight secondary ion mass spectrometry; Adsorption; Surface chemistry

INTRODUCTION

The source of NO_x can be classified broadly into both stationary and mobile sources. In this study, combustion flue gas was selected as the object of stationary source. Main NO_x control techniques that are utilized commercially are selective catalytic reduction (SCR) and selective noncatalytic reduction (SNCR). However, these methods have a few problems. First, the SCR has a problem of catalytic deactivation caused by the catalyst poisoning and requires high installation and maintenance fees. On the other hand, SNCR requires a range of operation temperatures that is higher and narrower than that of SCR. Secondly, these methods cannot be applied to NO_x such as the fuel gas, which has a low concentration level (1–3).

In general, the adsorption method not only requires small electrical consumption but also does not generate secondary pollution. In addition, it has merits in that its design is simple and requires only a small space when installed. Granular activated carbon (GAC) has been used widely in treating harmful gas in the air due to its hydrophobic property, high surface area, and intrinsic pore structure. Granular activated carbon has high adsorption capacity towards volatile organic compounds that have low concentrations. But it is observed that it has relatively low adsorptivity toward some inorganic compounds such as NO_x (4–15). Due to this, studies are being conducted for the last several years on impregnated activated carbon to which chemical activity is given by a method that impregnates selective chemical substances.

In terms of the choice of impregnant, those that form stable chemical compounds or modify into harmless gas through a chemical reaction with NO_x should be selected. Studies conducted so far report that adding of basic functional group has a good efficiency level on the selective adsorption of NO_x (16–20). Alkali and alkali-metal compounds have been utilized for catalysis for a long time. Theoretical substance of this catalysis is known as basic surface OH^- ions



caused by alkaline metal hydroxides (21). In this study, KOH is selected because it is known as the most basic alkaline metal hydroxide among all hydroxides.

Time of flight secondary ion mass spectrometry (ToF-SIMS) is an attractive choice for studies of surface chemistry because it offers extreme surface sensitivity, very low detection limits (ppm or ppb), and, when combined with the time-of-flight capability, permits very high mass resolution to differentiate similar mass fragments. Despite these obvious advantages, there has been little work published on the use of ToF-SIMS in adsorption studies (22). Thus, the surface chemistry on KOH-impregnated activated carbon (K-IAC) before and after NO_x adsorption was examined by performing ToF-SIMS and SIMS depth profile.

The purpose of this study was, through a breakthrough experiment by use of fixed-bed adsorption column, to examine selective adsorption characteristics and surface chemistry according to NO_x that was adsorbed on K-IAC.

EXPERIMENTAL

Preparation of KOH Impregnated Activated Carbons

The adsorbent was prepared by impregnating KOH (Junsei Chemical Co., Japan) solution into GAC obtained from coconut shell (Dongyang Carbon Co., Korea). The GAC was sieved through a 8/16 mesh and treated with N₂ flowing for an hour at 383K, and then for 4 hr at 413K. Next, the treated GAC was dried at 383K. KOH was impregnated in an aqueous solution state into the GAC via incipient wet impregnation (by mixing 15 g of GAC with a 10 M KOH solution in a 500-mL glass-stoppered flask). The flask was immersed in a constant-temperature shaker bath, with a shaker speed of 100 rpm. The mixing was performed at 85°C and lasted for 3 hr. After mixing, the GAC slurry was subjected to vacuum drying at 383K. Thereafter, the sample was filtered, washed with distilled water, and dried at 403K. The KOH-impregnated sample was activated in a stainless-steel column placed in a vertical furnace under a stream of purified N₂, with a flow rate of 100 mL/min. Manufactured K-IAC was stored in a desiccator to prevent adsorbent function reduction by common airborne moisture and contaminants. At this time, precautions were taken for impregnation, drying, and storage of adsorbent because the processes have great influence on the adsorption capacity. In order to analyze quantitatively the amount of impregnated potassium on K-IAC, impregnated activated carbon was crushed to less than 100 μm. Then, a mixture of 0.1 g of the sample and 5 mL of nitric acid was heated for 30 min at 353K. Then it was boiled at 423K until it turned into a gel. After elution of the sample was finished, 50 mL of distilled water was added for filtering. Then, the amount of impregnated potassium was analyzed via atomic



absorption spectrophotometry (AAS). Through AAS analysis, potassium loading of K-IAC was confirmed to be 9.96 wt%.

Apparatus and Method

The fixed-bed adsorption system used in this experiment is shown in Fig. 1. Material of the fixed-bed adsorption column was a 316 stainless-steel tube, with an inside diameter of 10.9 mm, and 400 mm length. Inside the columns, a steel mesh was placed in the upper and lower extremities of the adsorbent to support the samples and minimize channeling phenomenon. Temperature of the column was maintained with an electric furnace located at its outer wall. For the system line, temperature was maintained by using a heat band and heat insulating material and was regulated with a proportional-integral-differential (PID) temperature controller (Hanyoung Electronic Co., HY-100, Korea). The temperature was measured by connecting a K-type thermocouple (Omega Engineering Inc.), located inside the line, to a recorder. Each certified 2% NO/N₂ and 5000 ppm NO₂/N₂ was diluted to the desired concentration range of near 150 and 262 ppm via a mass flow controller (Brooks Co., 5280E, Japan). Purified air containing 20.9% O₂ was used for the experiment via the addition of oxygen. In the fore end of the adsorption column, an in-line static mixer was installed to

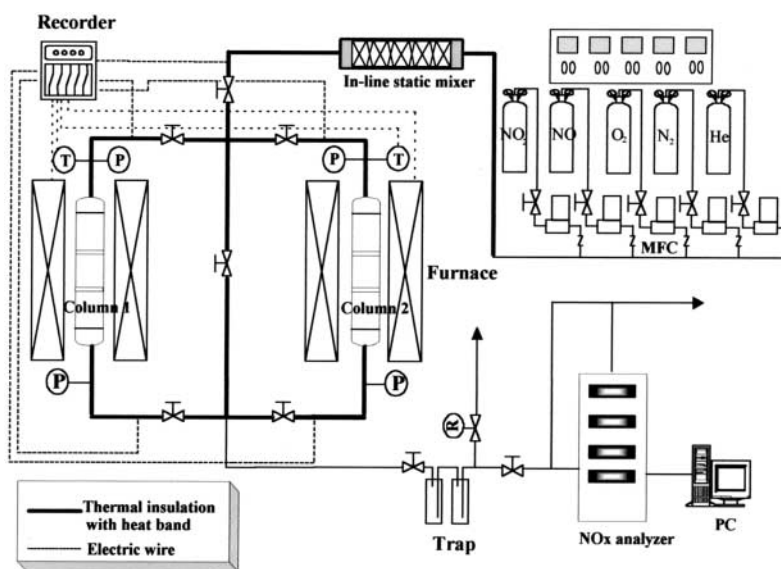


Figure 1. Schematic diagram of the experimental system.



facilitate mixing. Concentrations of NO and NO₂, which exhausted from the bypass line and adsorption column, were analyzed by using a chemiluminescent NO_x analyzer (Thermo Environmental Instruments Inc., 42C, USA). Daily NO_x analyzer calibrations were performed with N₂ (zero value) and NO and NO₂ gases certified by manufacturer analysis having a concentration of near 80% of the analyzer full-scale range (span value). During the adsorption experiment, analyses on column outlet concentrations of NO, NO₂, and NO_x were controlled with software (Thermo Environmental Instruments Inc., C series, USA). Analytical data were captured every minute and read into a computer. To purge impurities from the system line before an adsorption was made it was flowed with He for 30 min at the flow rate of 500 mL/min at 473K. Then, the temperature was reset to experimental value, and the column was packed with adsorbent and re-purged with He for 10 min. Then, the zero value of NO_x analyzer was checked before proceeding with the experiment.

Surface Characterization

Before and after adsorption, surface analyses were conducted for samples by using SEM (Hitachi, S-1400, Japan) and static type ToF-SIMS (Perkin-Elmer, PHI-700 ToF-SIMS/SALI, USA).

The ToF-SIMS analysis was carried out using a system equipped with a two-stage reflectron-type analyzer. A low dose and pulsed Cs⁺ primary ion beam, whose impact energy was 10 keV, was employed. The spectrometer was run at an operating pressure of 10⁻⁹ mbar. The primary ion beam was directed on a square area of 50 μm × 50 μm. The system was operated in high sensitivity mode with a pulse width of 50 nsec and with a beam current of 0.5 nA, resulting in a primary ion dose of approximately 4 × 10¹¹ ions per cm² analysis. The SIMS spectra were acquired over a mass range of $m/z = 1-100$ in negative modes.

RESULTS AND DISCUSSION

The Effect of KOH Impregnation

The conditions of experiment conducted to remove NO_x from Run 1 to Run 7 are summarized in Table 1. In order to confirm the effect of K-IAC, the breakthrough curve of NO_x comparing K-IAC (Run 2) and GAC (Run 1) in the absence of oxygen is shown in Fig. 2. The GAC became breakthrough as soon as the adsorption started and showed $C/C_0 = 0.75$ in 120 min. However, K-IAC was only about $C/C_0 = 0.25$. Comparing the adsorbed amounts, GAC recorded only 0.01 mmol NO_x/g GAC, whereas K-IAC showed 0.04 mmol NO_x/g K-IAC, which is four times higher



Table 1. Conditions of Each Adsorption Experiment

Run No.	Adsorbent	Adsorbate	NO Concentration (ppm)	NO ₂ Concentration (ppm)	Contact Time (sec)	Linear Velocity (cm/sec)	Temperature (K)
1	GAC	NO ₂ /N ₂	9	253	2.244	10.627	403
2	K-IAC	NO ₂ /N ₂	9	253	2.244	10.627	403
3	K-IAC	NO ₂ /air	3.6	138.2	0.185	10.803	303
4	K-IAC	NO ₂ /air	4.1	137.6	0.185	10.803	353
5	K-IAC	NO ₂ /air	3.8	147.6	0.185	10.805	403
6	K-IAC	NO ₂ /N ₂	3.6	144	0.185	10.807	403
7	K-IAC	NO ₂ /air	4.4	145.1	0.064	31.388	403

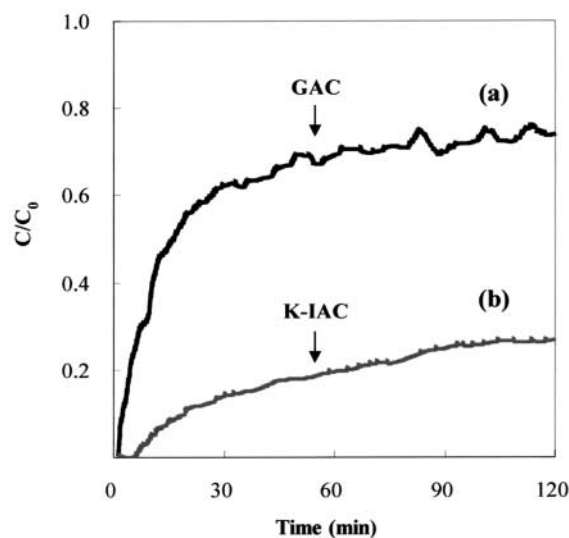


Figure 2. A comparison of breakthrough curves over GAC and K-IAC: 262 ppm of NO_x (with 253 ppm NO₂ and 9 ppm NO), flow rate = 591 mL/min (N₂ balance), sample amount = 12.725 g, adsorption temperature = 403K, linear velocity = 10.627 cm/sec, contact time = 2.244sec. (a) Run 1—NO_x/GAC; (b) Run 2—NO_x/K-IAC.

than that of GAC. Such a result confirms that K-IAC shows a good selectivity with NO_x, and it can be determined that KOH provided strong basic functional group to the GAC, playing an important role in providing adsorption site to allow selective adsorption of NO_x. That is, K-IAC at NO₂ adsorption is the effect of high selectivity of surface basic OH⁻ ions with NO₂ due to KOH impregnation. This can be interpreted that the type of NO_x adsorption on K-IAC forms oxide crystals of KNO_x ($x = 2$ or 3) that are ionic chemical compounds due to potassium and occupies selective adsorption site. This is because potassium has a high reactivity and cannot exist as a single element substance but exists as a chemical compound bonded with other elements.

Influence of Linear Velocity

Figure 3 shows a tendency of NO_x adsorption for different linear velocities, i.e., 10.805 (Run 5) and 31.388 cm/sec (Run 7) after altering the flow rate at near 150 ppm NO_x/air. Comparing the adsorbed amount for 630 min, 10.805 cm/sec recorded only 0.35 mmol NO_x/g K-IAC, whereas 31.388 cm/sec of linear velocity showed 2.97 mmol NO_x/g K-IAC, which is 8.5 times higher than that of



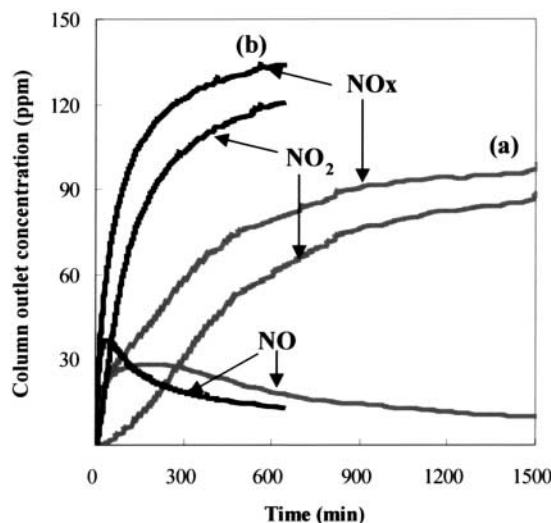


Figure 3. NO_x breakthrough curves over K-IAC for linear velocity variation: near 150 ppm of NO_2 (with 145–148 ppm NO_2 and 3.8–4.4 ppm NO), air balance (with 20.9% O_2), sample amount 1.067 g, adsorption temperature = 403K. (a) Run 5—10.805 cm/sec; (b) Run 7—31.388 cm/sec.

10.805 cm/sec. When the linear velocity is 31.388 cm/sec, gradients of concentration curves in the NO and the NO_2 became steeper. This is because even if the concentration of NO_x is the same, the higher the linear velocity introduced in the column, the larger the absolute amount of NO_x becomes, reducing the breakthrough time and reaching the saturated point faster. That is to say, as the linear velocity in K-IAC increases, the fast occurrence of catalytic conversion from NO_2 to NO leads to higher early concentration of NO and then the selective adsorption sites for NO_x correlatively get lost in a quick mode. This increases the adsorbed amount for NO_x at high linear velocity but results in relatively shorter breakthrough time.

Influence of Temperature

Figure 4 shows the effect of temperature for NO_x adsorption. It was performed at 303K (Run 3), 353K (Run 4), and 403K (Run 5) in the presence of oxygen. The experiment showed that breakthrough progressed slowly at a high temperature of 403K. Particularly, breakthrough was slower in the range between 353 and 403K than in the range between 303 and 353K. This phenomenon can be considered in three separate aspects. First, it is presumed to be because, as the



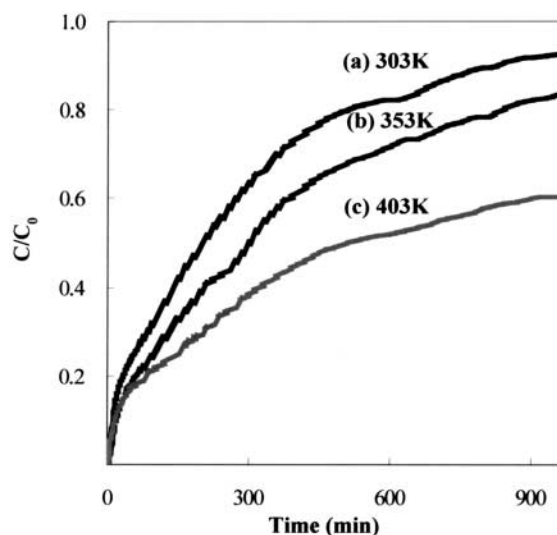
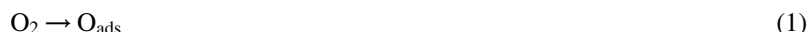


Figure 4. NO_x breakthrough curves over K-IAC for temperature variation: near 150 ppm of NO₂ (with 137–148 ppm NO₂ and 3.6–4.1 ppm NO), air balance (with 20.9% O₂), sample amount 1.067 g, linear velocity = 10.803–10.805 cm/sec, contact time = 0.185 sec. (a) Run 3—303K; (b) Run 4—353K; (c) Run 5—403K.

temperature increases, NO₂ that reacts with KOH goes beyond activation barrier, and its collision fraction, which has a large collision energy enough to cause reaction with K⁺, increases. Secondly, it is because, as in Eq. (1),



chemisorption of oxygen in an atomic state to K-IAC is achieved better at high temperature. As NO₂ adsorption is in progress, there also occurs a conversion phenomenon of NO to NO₂ by the chemisorbed oxygen. Thus, it can be said that adsorptivity improved compared with nonexistence of oxygen. Thirdly, in the condition of low temperature at which H₂O can exist on the surface, it may lose adsorptivity by blocking the pore by being condensed on the surface as HNO₃ with NO₂ adsorption.

Influence of Oxygen

Researchers have already reported the fact that adsorption efficiency increases considerably by the addition of oxygen in NO_x adsorption (13,23). Figure 5 shows a breakthrough curve for NO_x in the states where oxygen exists or does not. As a result,



as shown in Fig. 5 (a, Run 6), when no oxygen was present, the adsorbed amount of NO_x was 1.40 mmol NO_x/g K-IAC from 960 min of reaction, while in the presence of oxygen as shown in Fig. 5 (b, Run 5), the adsorbed amount is 0.55 mmol NO_x/g K-IAC. The oxygen addition showed a 2.5 times higher adsorbed amount for NO_x . It seems that the difference is caused by Eq. (2).



Therefore, Fig. 5 (b) can be interpreted as adsorption efficiency improved in a repeated process in which NO generates due to NO_2 adsorption and, with the addition of oxygen, reaction of Eq. (2) occurs again according to Eq. (1) through atomic-state oxygen, which was chemisorbed to the surface at different adsorption sites.

Surface Characterization

Scanning Electron Microscopy Study

Figure 6 shows the images observed, by using SEM at the magnification of $300\times$, $1000\times$, and $30,000\times$ from top to bottom, about the process in

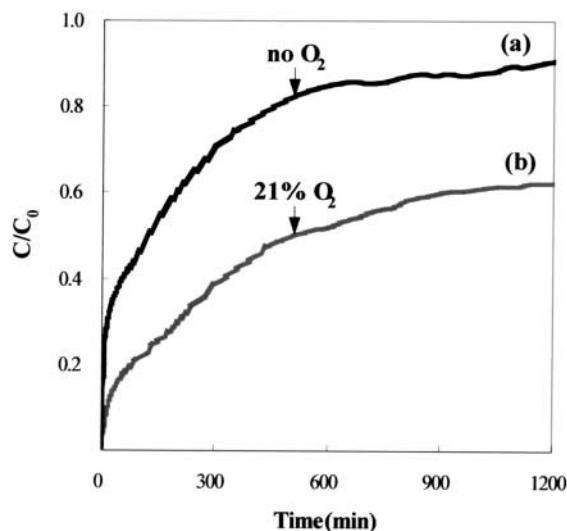


Figure 5. NO_x breakthrough curves the absence and the presence of oxygen: near 150 ppm of NO_2 (with 144–148 ppm NO_2 and 3.6–3.8 ppm NO), sample amount = 1.067 g, adsorption temperature = 403K, linear velocity = 10.805–10.807 cm/sec, contact time = 0.185 sec. (a) Run 6—no O_2 ; (b) Run 5—21% O_2 .



which NO and NO_2 are adsorbed to K-IAC. It shows that the surface of nonadsorbed K-IAC in Fig. 6(a) was clear and countless pores exist in various sizes. In terms of types of pores, it has a structure of branched pores in which mesopores exist in macropores and micropores develop in mesopores. These pores show a phenomenon in which they gradually get filled as certain crystals from micropores to macropores in the order (a) \rightarrow (c) \rightarrow (d) of Fig. 6. In addition, it can be expected that the selective adsorption sites get lost with the growth of some generated crystals that block the pores. At less than 373K, HNO_3 ($T_b \approx 393\text{K}$) can be generated on the surface during the reaction due to H_2O production (13). The condition of this experiment is 403K and, therefore, it is expected that the pores are occupied by KNO_x , which constitute the stable-crystal state by forming ionic bond with NO_x by K^+ . Figure 6(b) shows the SEM image performed for NO . NO is adsorbed into micropores in a small quantity in the form of NO_2 by oxygen complex type functional group that exists in the existing GAC, which is different from Fig. 6(a).

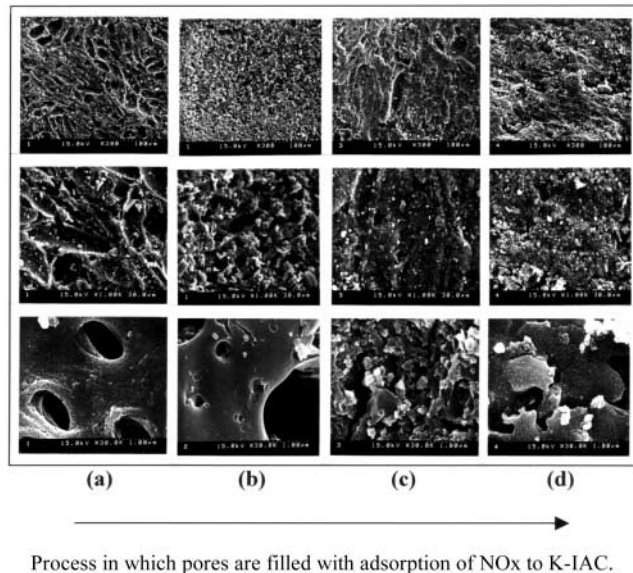


Figure 6. The SEM photograph of K-IAC: (a) nonadsorbed; (b) 2 hr NO/N_2 adsorbed ($C/C_0 = 0.98$); (c) 2 hr NO_2/N_2 adsorbed ($C/C_0 = 0.48$); (d) 50 hr NO_2/N_2 adsorbed ($C/C_0 = 0.97$).



Time of Flight Secondary Ion Mass Spectrometry Study

The surface composition and chemistry of K-IAC were studied using ToF-SIMS. In dealing with gas–solid reaction, researchers generally use x-ray photoelectron spectroscopy (XPS) and Auger electron spectroscopy (AES) that have a good quantification, provide information on chemical states, and allow easy data interpretation. In these instruments, however, the elemental sensitivity limit is 0.1% and molecular identification is impossible. To analyze low concentration NO_x in which adsorption occurs on K-IAC that is composed of organic and inorganic complex including hydrogen, it can be quite informative to use ToF-SIMS that has a very good sensitivity even at the ppm unit and in which simultaneous analysis of organic and inorganic compound is possible (24,25). While ToF-SIMS has the above-mentioned merits, it has the following shortcoming as an instrument. In quantitative analysis, the ToF-SIMS is not proportionate to the surface concentration absolutely and fragment peaks make interpretation difficult. Therefore, it is necessary to do careful calibration.

In this experiment, background was calibrated by comparing Inductively coupled plasma-atomic emission spectroscopy (ICP-AES; Labtest Plasmascan 710, USA) and ToF-SIMS for a sample whose concentration was known. At the time of analyzing NO_x adsorbed K-IAC, their tendencies were interpreted by comparison with nonadsorbed K-IAC, increasing the reliability of the data.

In Fig. 7, the results of surface analysis are indicated by using ToF-SIMS with sample under the conditions of nonadsorbed and NO_x adsorbed K-IAC of $C/C_0 = 0.42$. In the results from polarity of ions detected from analysis, the negative range that provides information on main peaks in the interaction between KOH and NO_x was 1–100 m/z . In NO_x adsorbed K-IAC, the following main ions were discovered. In the negative spectrum, the peaks of increased ions compared with nonadsorbed K-IAC were CN^- ($m/z = 26$), CNO^- ($m/z = 42$), NO_2^- ($m/z = 46$), and NO_3^- ($m/z = 62$), while the peaks of decreased ions were H^- ($m/z = 1$), C^- ($m/z = 12$), CH^- ($m/z = 13$), O^- ($m/z = 16$), C_2^- ($m/z = 24$), C_2H^- ($m/z = 25$), O_2^- ($m/z = 32$), KO^- ($m/z = 55$), and CO_3^- ($m/z = 60$). When the nonadsorbed and NO_x adsorbed K-IAC are compared, NO_2^- and NO_3^- that hardly existed before adsorption were generated after adsorption at high intensity. Therefore, we could understand that NO_x adsorption progressed at selective adsorption sites in the form of NO_2^- and NO_3^- . That is to say, NO_2^- and NO_3^- after adsorption analysis by ToF-SIMS bonded on the surface with K^+ and produced crystals of KNO_2 and KNO_3 . Some reduction of OH^- after adsorption indicates that there still remain selective adsorption sites for NO_x . OH^- that participated in selective adsorption produces H_2O through reaction with NO_x . At this time, it vaporizes at the experimental condition of 403K and does not exist on the surface. However, OH^- that forms a bonding as nonreactive KOH and occupies a selective adsorption site appears with SIMS analysis due to high T_b . In



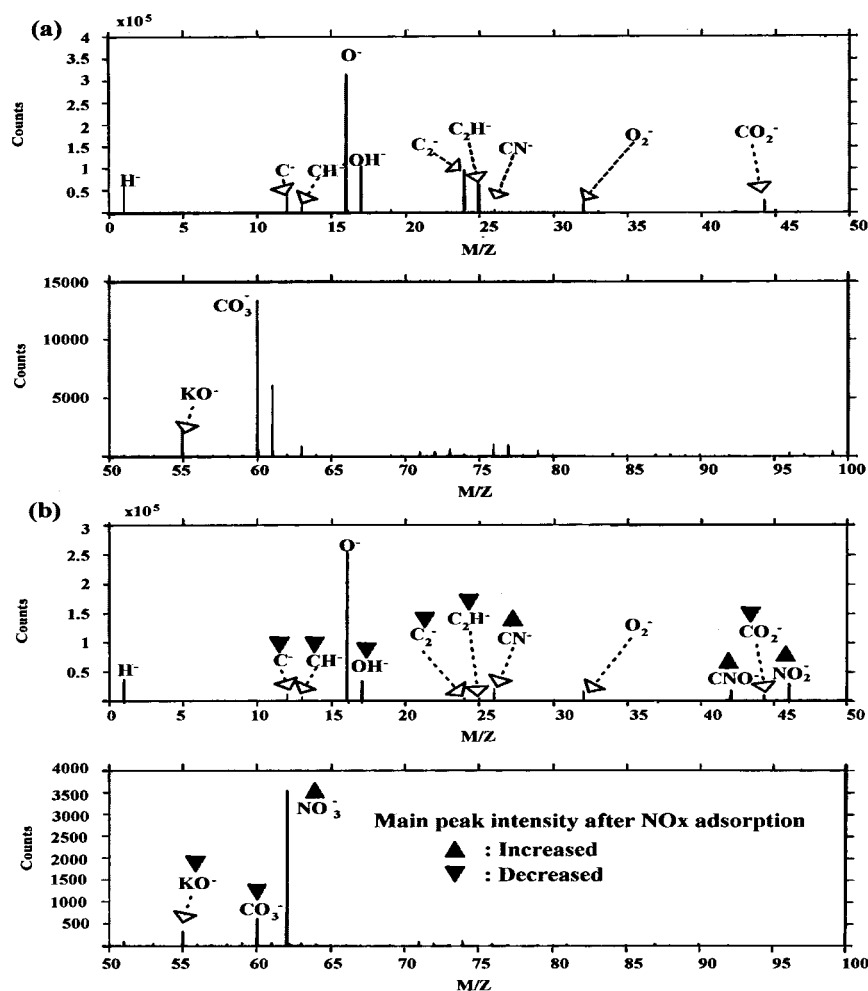


Figure 7. The ToF-SIMS negative spectra: (a) nonadsorbed on K-IAC; (b) NO_x adsorbed on K-IAC ($C/C_0 = 0.48$, adsorbed for 2 hr with near 150 ppm of inlet NO_x concentration at 403K, Run 6).

the ToF-SIMS spectra of K-IAC, the C_xH^- ($x = 1, 2$) and C_x^- ($x = 1, 2$) peaks were assigned to aromatic carbons with and without bonds to hydrogen, respectively (26). The CO_2^- and CO_3^- peaks were due to oxygen complex functional group of activated carbon. As in Fig. 7, ion counts of nitrogen-containing species are increased on the K-IAC by NO_x adsorption. It can be considered that CN⁻ is converted with bond cleavage of C_xH^- , CO_2^- , and CO_3^-



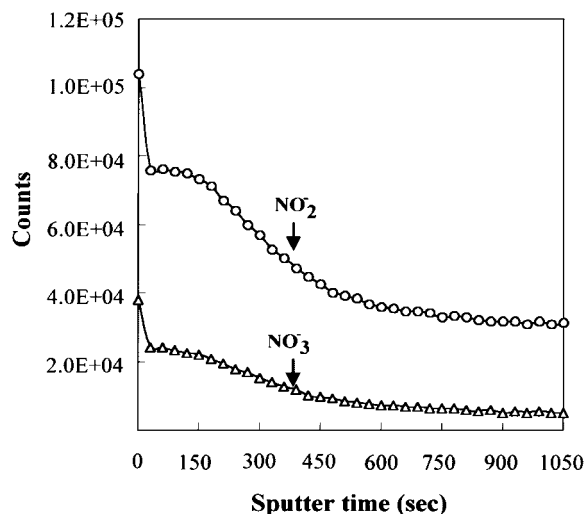


Figure 8. The SIMS depth profile of K-IAC for NO_3^- and NO_2^- ions obtained from K-IAC with $C/C_0 = 0.48$ (adsorbed for 2 hr with near 150 ppm of inlet NO_x concentration at 403K, Run 6).

by NO_x adsorption. Reduction of C_x^- , C_xH^- , CO_2^- , and CO_3^- , and formation of CNO^- support this fact.

Secondary Ion Mass Spectrometry Depth Profiles

In SIMS depth analysis, secondary ion counts were indicated as a function of sputtering. Sputter depth is about 60 Å for every 1 min on the basis of Si. NO_2^- , NO_3^- , and KO^- among the main negative peaks analyzed in Fig. 7 showed a sputter-depth profile. It illustrates differences in the number of count by sputter time of main ionic species for nonadsorbed K-IAC and NO_x adsorbed K-IAC that shows a breakthrough progress of $C/C_0 = 0.42$.

Figure 8 shows the depth profiles of NO_2^- and NO_3^- with diffusion of NO_x into pores. Due to a bond formation with the potassium ion, NO_x exist in pores as KNO_2 and KNO_3 . In depth profile results, ion counts of NO_2^- and NO_3^- decreased rapidly to about 42,557 and 9647, respectively, due to predominant external diffusion on the surface by NO_x up to 450 sec and slowly decreased and stayed at about 31,207 and 5069 up to 1050 sec. The differences in the relative counts ratios of NO_2^- to that of NO_3^- are about three times for up to 450 sec and six times for up to 1050 sec. That is to say, in accord with the increase in the sputter time



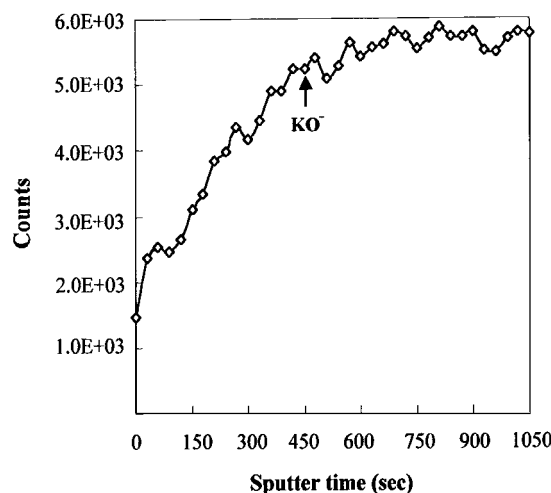


Figure 9. The SIMS depth profile of K-IAC for KO^- ion obtained from K-IAC with $C/C_0 = 0.48$ (adsorbed for 2 hr with near 150 ppm of inlet NO_x concentration at 403K, Run 6).

(or depth), ion counts of NO_3^- decrease extremely. This phenomenon is due to predominant KNO_3 on the external surface of K-IAC. In addition, the existence of KNO_3 is dependent on the oxidation of produced KNO_2 on the K-IAC by NO_x adsorption.

Figure 9 shows the depth profiles for KO^- . In the depth profile for KO^- , the question of whether KOH is connected directly with the existence of selective adsorption sites or not was verified. The sputter time increased rapidly from 0 to 450 sec. After 450 sec, it showed a tendency to increase slowly. The pattern of this phenomenon was contrary to that of depth profile at NO_2^- and NO_3^- in Fig. 8. When examined by depth profile, NO_2^- and NO_3^- were adsorbed more at the selective adsorption sites up to a sputter time of 450 sec when there occurred a relatively higher NO_x adsorption. From this, we can conclude that increased NO_2^- and NO_3^- brought a decreased phenomenon of KO^- as in Fig. 9. That is, KOH provides selective adsorption sites for NO_x .

Predicted Chemical Reaction by a Breakthrough Trend and Surface Characterization

NO_x had the following characteristics in the chemical reaction with KOH, which was impregnated to the surface. Fig. 10 shows a representative



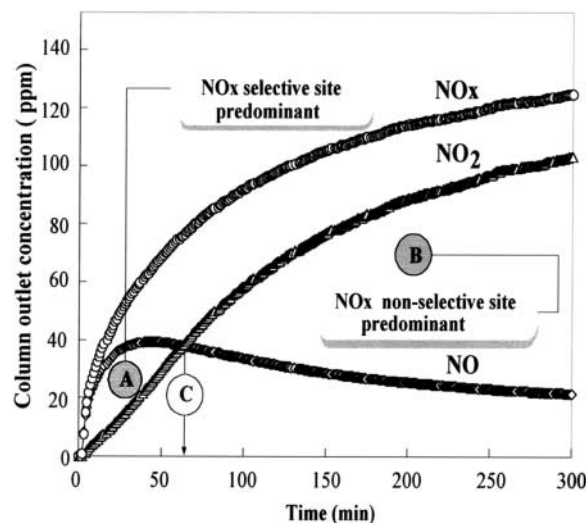


Figure 10. Representative concentration curve of NO_x adsorption on K-IAC.

tendency on K-IAC of NO_2 adsorption in the experiment. NO_x selective adsorption sites were predominant in the surface state of A area compared with that of B area, so more NO was generated than NO_2 in A area. The B area becomes the opposite of A area. The B area is the point at which concentration of NO_2 becomes higher than that of NO. Even afterwards, however, NO was generated continuously for a long time. Here, it can be argued that, to improve adsorption capacity of NO_x , the condition of experiment in which A area is made broad by delaying C point is an optimum condition of this reaction.

Figure 11 shows the expected reaction mechanism from adsorption of NO_x on K-IAC. NO_2 is adsorbed to the surface by chemical reaction with KOH and generates H_2O by forming KNO_2 and KNO_3 that are composed of stable ionic bond-type crystals. With continuous adsorption with NO_2 , the generated KNO_2 is oxidized in the end, becomes KNO_3 and releases NO. At low temperature, however, H_2O forms HNO_2 and HNO_3 with NO_2 adsorption. HNO_2 exists as a thermodynamic equilibrium state with NO_x , and HNO_3 may become a factor that reduces adsorptivity by blocking the selective adsorption sites.

It can be said that the effect of impregnation of KOH is to provide basic OH^- ions to GAC and play a role that delays the rate of oxidation to KNO_3 by NO_x . In addition, K^+ helped the stable adsorption of NO_x on K-IAC.



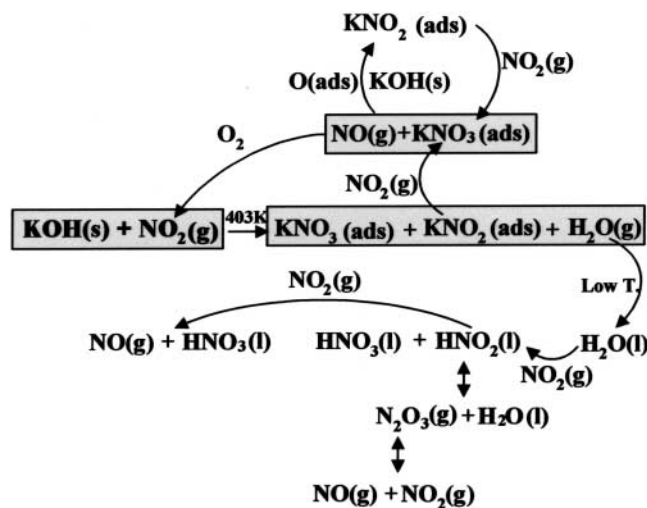


Figure 11. Predicted reaction mechanism of NO_x over K-IAC.

CONCLUSION

This study was done, first, to understand the adsorption characteristics of NO_x through a breakthrough experiment by using a fixed-bed adsorption column and secondly, based on this, to examine the surface chemistry according to NO_x that was adsorbed on the K-IAC. The K-IAC confirmed that the adsorption was mostly due to chemical reaction. NO₂ adsorption had an adsorptivity that was four times higher than that of GAC. NO₂ is adsorbed by reaction with impregnated KOH, and then NO is generated because of it. At 403K, which is an established experimental condition, good adsorptivity is expected because the existence of H₂O and HNO₃, which may be generated in the surface due to side reaction, may be blocked and chemisorption of oxygen is relatively well done. When oxygen is present, this NO was adsorbed as NO₂ by oxygen that was chemisorbed in the atomic state on KIAC and increased the adsorptivity. The main chemical composition was analyzed for pre- and post-adsorption of NO_x by using ToF-SIMS and surface chemistry and was confirmed by performing SIMS depth profile. Decrease of C_x⁻, C_xH⁻, CO₂⁻, and CO₃⁻ on K-IAC with progress of NO_x adsorption has to do with the increased conversion to CN⁻ and creation of CNO⁻ supports it. The OH⁻ in existing K-IAC generated H₂O by reaction with NO_x, vaporized, and decreased at 403K, which was the experimental condition.

That the selective adsorption site was composed of KOH can be explained as a phenomenon in which NO₂⁻ and NO₃⁻ produce crystals of KNO₂ and KNO₃



by K^+ and increase the surface distribution. A depth profile of KO^- confirmed that KOH provides a selective adsorption site for NO_x . The studies on adsorption reaction and surface chemistry showed that the basic surface OH^- ions, which were well developed on the surface due to impregnation of KOH to K-IAC, showed high selectivity with NO_2 and improved adsorptivity by leading basic character on K-IAC and delaying the rate of oxidation to KNO_3 . In addition, K^+ by NO_2 adsorption played a catalyst role that adsorbs crystals of KNO_2 and KNO_3 that are ionic compounds to the surface.

NOMENCLATURE

C	effluent gas concentration (ppm)
C_0	influent gas concentration (ppm)
T_b	boiling temperature (K)

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